

01/05/01

JC961 U.S. PTO

01-08-01

A

Atty. Docket No. AMAT/5538/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
 Assistant Commissioner of Patents and Trademarks
 Washington, D.C. 20231

Re: Inventor(s): LIZHONG SUN, STAN D. TSAI, SHIJIAN LI and FENG LIU
 Title: TANTALUM REMOVAL DURING CHEMICAL MECHANICAL POLISHING

JC961 U.S. PTO
 09/755717
 01/05/01

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 27 pages.
- ☒ Drawings totaling 3 pages, ☒ Formal ☐ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☐ Information Disclosure Statement w/ Form 1449 and References.
- ☒ Assignment of the invention to **Applied Materials, Inc.**
- ☒ Assignment Recordation Cover Sheet

FEE CALCULATION

Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	67	-20=	47	x \$18.00	\$846.00
Independent Claims	4	-3=	1	x \$80.00	\$ 80.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$1636.00

- ☒ The Commissioner is hereby authorized to charge \$1636.00 to Deposit Account No. 50-1074/5538/RWM.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074/5538/RWM. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
 Legal Affairs Department
 P.O.BOX 450A
 Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D C 20231

Express Mail Receipt No. EL684621816US

Date of Deposit 1/5/2001

Signature Robert W. Mulcahy

Respectfully submitted,

Robert W. Mulcahy
 Registration No. 25,436
 (713) 623-4844